

PATENT

Docket No.: JCLA4539-CA

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: DAVID LIN )  
Filed: HEREWITH )  
For: METHOD FOR PROCESSING A FILM )  
Examiner: MAYES, M )  
Group Unite: 1734 )

JC857 U.S. PTO  
10/083851  
02/25/02

**INFORMATION DISCLOSURE STATEMENT**

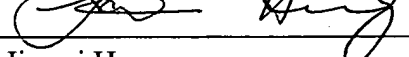
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed is form PTO-1449 listing 13 reference(s) that are also enclosed. This Information Disclosure Statement is being filed with this application, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1).

Respectfully submitted,

Dated: 2/25/2002

By:   
Jiawei Huang  
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